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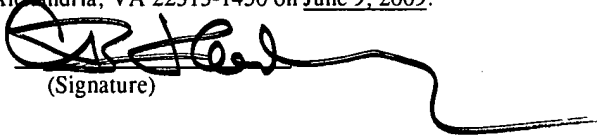
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA, et al.
Serial No. : 10/526,205
Filed : March 1, 2005
For : ANODIC OXIDATION METHOD, TITANIUM
OXIDE FILM MANUFACTURING METHOD
AND CATALYST CARRYING METHOD
Group Art Unit : 1742
Examiner : William T. Leader

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(Name)


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INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation together with
copies of the documents referred to therein.

Respectfully submitted,

Jordan and Hamburg LLP

By 

C. Bruce Hamburg
Reg. No. 22,389
Attorney for Applicants

Jordan and Hamburg LLP
122 East 42nd Street
(212) 986-2340